FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office	Docket No.: INTEL1260-1 (P14246X)	Application No.: 10/680,583
	Applicants: Chan et al.	Confirmation No.: 5278
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U.S. PATENT DOCUMENTS

EXAM. INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
K.G.	AA	5,567,628 A	10/22/1996	Tarcha et al.	—	—	
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EXAMINER Kara Geisel	DATE CONSIDERED 12/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
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